

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Allan Rosencwaig et al.

Application No.: 09/629,407

Filed: August 1, 2000

For: MEASUREMENT OF THIN FILMS

AND BARRIER LAYERS ON

PATTERNED WAFERS WITH X-RAY

REFLECTOMETRY

Confirmation No.:

Group Art Unit: 2876

Examiner: H.K. Song

SUBMISSION OF FORMAL DRAWINGS

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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope, addressed to: Commissioner for Patents, Washington, DC 20231 on February 18, 2003.

Commissioner for Patents Attn: Official Draftsperson Washington, D.C. 20231

STALLMAN & POLLOCK LLP

Sir:

Enclosed are three (3) sheets of formal drawings for filing in the above-referenced application.

Respectfully submitted,

STALLMAN & POLLOCK LLP

Dated: February 18, 2003

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Atty Docket No.: TWI-10820